



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Satoshi KIKUCHI, et al.

SERIAL NO: 09/846,255 ✓

GAU: 2813

FILED: May 2, 2001 ✓

EXAMINER: L.M. Schillinger

FOR: CLEANING PROCESS FOR SUBSTRATE SURFACE

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

RECEIVED
APR 10 2003
TECHNOLOGY CENTER 2800

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

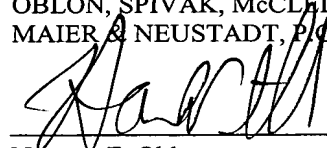
It is hereby requested that a **two** month extension of time be granted to April 6, 2003 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Notice of Appeal. A timely response to the final rejection, due February 6, 2003 has not been filed. **A Request for Continued Examination is being filed concurrently herewith.**
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$410.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. **15-0030**. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


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